

Next-generation ultra-high-speed microwave Photonic integrATed circuiTs using advancEd hybRid iNtegration



PATTERN'S MAIN GOALS

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PATTERN addresses many challenges in microwave photonics and PICs at the same time. The main project goals are to:

Integrate all major photonic functionalities on a single hybrid PIC: light generation, transmission, manipulation and detection, as well as electronic co-integration.

Pave the way for a **new generation of advanced PICs** with **unrivalled novel** functionalities, which will serve a wide range of applications from telecom and 5G/6G to quantum, LiDAR, optical computing, and sensing technologies.

HETEROGENEOUS INTEGRATION METHODS



ALL FUNCTIONS ON ONE CHIP

PATTERN'S ALL-IN-ONE PIC PLATFORM



OBJECTIVES

- Develop new advanced PIC building blocks on an LNOI platform, enhance 1 their fabrication quality and yield
- Develop the **design flow** for the **ultra-high-speed microwave photonic systems** 2
 - Develop processes for hybrid integration of InP and Si on top of LNOI based on > flip-chip bonding (target specifications: below 1 dB / facet optical insertion losses and < 0.5 dB RF losses)
 - > micro-transfer printing
- Develop a **1550 nm LNOI InP fast tunable laser** 4
- Realise six **PIC prototypes** for the end-user partners in the PATTERN consortium 5



Property	InP	On-chip YIG	LNOI	PATTERN Hybrid platform
Transparency window	0.9 to 2 µm	1.5 to 8 µm	0.3 to 5.5 µm	O
Bandgap	1 eV	2.5 to 3 eV	4.9 eV	O
Propagation losses	1.5 to 3 dB/cm	3 dB/cm	< 0.1 dB/cm	
Two-photon absoprtion	High	Very low	Very low	Sic N
Electro-optic coefficient	Notintrinsic	No	High (31 pm/v)	SOL
Optical gain	Yes	No	No	lnt
Detectors	Yes	No	No	egro
Magneto-optics (isolator)	No	Yes	No	✓ atio
Piezo-electricity (acousto-optics)	No	No	Yes	

Academic research



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Industry status



Project funded by

Ramping up

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Swiss Confederation

Federal Department of Economic Affairs, Education and Research EAER State Secretariat for Education Research and Innovation SERI

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